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## \*BIBDATASHEET\*

CONFIRMATION NO. 5885

Bib Data Sheet

SERIAL NUMBER 10/054,373	FILING DATE 01/22/2002  RULE	CLASS 361	GROUP ART UNIT 2831	ATTORNEY DOCKET NO. AIBT 12K09
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\*\* CONTINUING DATA \*\*\*\*\*

OK

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

OK

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 02/19/2002

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <u>[Signature]</u> Initials <u>ABT</u>	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
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## TITLE

Semiconductor processing chamber substrate holder method and structure

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